

**Amendments to the Abstract:**

Please add an Abstract of the Disclosure submitted herewith on a separate page.



ABSTRACT

A vacuum treatment chamber generates disk-shaped workpieces with directly bondable surface. The chamber is a stand-alone chamber in ambient atmosphere and has a plasma discharge section. A gas supply is operatively connected with a gas tank arrangement predominantly containing nitrogen. A workpiece holding arrangement is formed by a magazine with a multitude of slits, each for a workpiece to be simultaneously treated in said vacuum treatment chamber.